

AK/2800

TSMC-00-166



May 13, 2003

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572  
20 McIntosh Drive  
Poughkeepsie, N.Y. 12603

#9/B  
Amend  
JUN 11/03  
RECEIVED  
7/15/03  
VW

TECHNOLOGY CENTER 2800  
JUN 10 2003

Subject: Serial No. 09/679,514 10/06/00  
Hung-Jen Hsu

"A METHOD TO IMPROVE PASSIVATION  
OPENINGS BY REFLOW OF PHOTORESIST  
TO ELIMINATE TAPE RESIDUE"

Grp. Art Unit: 2823 B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated April 1, 2003,  
please amend the above-identified application for patent as  
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first  
class mail in an envelope addressed to: Commissioner for Patents  
P.O. Box 1450, Alexandria, VA 22313-1450, on June 2,  
2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature [Signature]  
Date 6/2/03